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WASINGTON, DC 20004-2128			· 2822			
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Please find below and/or attached an Office communication concerning this application or proceeding.

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•		Application	on N .	Applicant(s)				
		09/832,86	67	YAMAZAKI ET AL.				
	Offic Action Summary	Examiner		Art Unit				
•		Monica L	ewis	2822				
Period fo	Th MAILING DATE of this commun r Reply	ication appears on the	cover sheet with the c	orrespondence addr	ess			
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1)🛛	Responsive to communication(s) file	ed on <u>26 August 2003</u>	ļ.					
2a)⊠	This action is FINAL . 2b) This action is non-final.							
3)□	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
Dispositi	on of Claims							
4)⊠	(a) Claim(s) <u>1-14 and 25-50</u> is/are pending in the application.							
•	4a) Of the above claim(s) is/are withdrawn from consideration.							
5)	Claim(s) is/are allowed.							
6)⊠	Claim(s) 1-14 and 25-50 is/are rejected.							
7)	Claim(s) is/are objected to.							
8)□	Claim(s) are subject to restrict	ction and/or election r	equirement.					
Applicati	on Papers							
9)☐ The specification is objected to by the Examiner.								
10)⊠	10)⊠ The drawing(s) filed on <u>31 January 2003</u> is/are: a)⊠ accepted or b)□ objected to by the Examiner.							
	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).								
11)☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.								
_	ınder 35 U.S.C. §§ 119 and 120							
* S 13)□ A si 3; a 14)□ A	Acknowledgment is made of a claim All b) Some * c) None of: 1. Certified copies of the priority 2. Certified copies of the priority 3. Copies of the certified copies application from the Internation is ee the attached detailed Office action incknowledgment is made of a claim force a specific reference was included of CFR 1.78. The translation of the foreign lart cocknowledgment is made of a claim force inches was included in the first sentification.	documents have bee documents have bee of the priority documental Bureau (PCT Rulen for a list of the certion domestic priority und in the first sentence anguage provisional apport domestic priority und domestic priority	en received. In received in Application received in Application to the transport of the specification of the specification of the specification and the specification of the spec	on No ed in this National Sted. e) (to a provisional at in an Application Director) eived. and/or 121 since a	pplication) ata Sheet. specific			
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U.S. Patent and Trademark Office PTOL-326 (Rev. 11-03)

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DETAILED ACTION

1. This action is in response to the amendment filed August 26, 2003.

Specification

2. The lengthy specification has not been checked to the extent necessary to determine the presence of all possible minor errors. Applicant's cooperation is requested in correcting any errors of which applicant may become aware in the specification.

Double Patenting

3. The nonstatutory double patenting rejection is based on a judicially created doctrine grounded in public policy (a policy reflected in the statute) so as to prevent the unjustified or improper timewise extension of the "right to exclude" granted by a patent and to prevent possible harassment by multiple assignees. See *In re Goodman*, 11 F.3d 1046, 29 USPQ2d 2010 (Fed. Cir. 1993); *In re Longi*, 759 F.2d 887, 225 USPQ 645 (Fed. Cir. 1985); *In re Van Ornum*, 686 F.2d 937, 214 USPQ 761 (CCPA 1982); *In re Vogel*, 422 F.2d 438, 164 USPQ 619 (CCPA 1970); and, *In re Thorington*, 418 F.2d 528, 163 USPQ 644 (CCPA 1969).

A timely filed terminal disclaimer in compliance with 37 CFR 1.321(c) may be used to overcome an actual or provisional rejection based on a nonstatutory double patenting ground provided the conflicting application or patent is shown to be commonly owned with this application. See 37 CFR 1.130(b).

Effective January 1, 1994, a registered attorney or agent of record may sign a terminal disclaimer. A terminal disclaimer signed by the assignee must fully comply with 37 CFR 3.73(b).

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4. Claims 1-14 and 25-50 are provisionally rejected under the judicially created doctrine of obviousness-type double patenting as being unpatentable over claim1-13 of copending Application No. 09/837,324. Although the conflicting claims are not identical, they are not patentably distinct from each other because they both deal with light emitting devices.

This is a <u>provisional</u> obviousness-type double patenting rejection because the conflicting claims have not in fact been patented.

In regards to claims 1-14, Yamazaki et al. ("Yamazaki") discloses the following:

- a) a channel forming region, n-type forming regions, gate, conductive films of various types and insulating films of various types (See Claims 1-13).

 In regards to claims 25-50, Yamazaki discloses the following:
- a) a channel forming region, n-type forming regions, gate, conductive films of various types, insulating films of various types, coloring layers, light emitting elements, pixels, impurity concentrations (See Claims 1-13).

Claim Rejections - 35 USC § 103

- 5. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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6. Claims 1, 2, 5-8, 13, 14, 39, 40, 43, 44, 49 and 50 are rejected under 35 U.S.C. 103(a) as obvious over Kamiura et al. (U.S. Patent No. 6,288,413) in view of Toshiba (Japanese Application No. 7-72675).

In regards to claim 1, Kamiura et al. ("Kamiura") discloses the following:

- a) a channel forming region (For Example: See Figure 1F);
- b) an n-type impurity region (5) adjacent to the channel forming region (For Example: See Figure 1F);
- c) an n-type impurity region (11) adjacent to the n-type impurity region (For Example: See Figure 1F);
- d) an n-type impurity region (12) adjacent to the n-type impurity region (For Example: See Figure 1F);
- e) a gate insulating layer (3) provided over the active layer (For Example: See Figure 1F);
- f) a gate electrode (4) provided over the gate insulating layer (For Example: See Figure 1F);
- g) a first conductive film (8) provided over the gate insulating layer (For Example: See Figure 1F); and
- h) first conductive film overlaps the channel forming region and the n type impurity region with the gate insulating layer interposed therebetween (For Example: See Figure 1F).

In regards to claim 1, Kamiura fails to disclose the following:

a) a second conductive film.

However, Toshiba discloses the use of a second conductive film (For Example: See Paragraph 12). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a second

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conductive film as disclosed in Toshiba because it aids in improving the element speed (For Example: See Paragraph 12).

Additionally, since Kamiura and Toshiba are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Kamiura.

In regards to claim 2, Kamiura discloses the following:

- a) a channel forming region (For Example: See Figure 1F);
- b) an n-type impurity region adjacent to the channel forming region (For Example: See Figure 1F);
- c) an n-type impurity region adjacent to the n-type impurity region (See Figure 1F);
- d) an n-type impurity region adjacent to the n-type impurity region (For Example: See Figure 1F)
- e) a gate insulating layer provided over the active layer (For Example: See Figure 1F);
- f) a gate electrode provided over the gate insulating layer (For Example: See Figure 1F);
- g) a first conductive film provided over the gate insulating layer (For Example: See Figure 1F); and
- h) first conductive film overlaps the channel forming region and the n type impurity region with the gate insulating layer interposed therebetween (For Example: See Figure 1F).

In regards to claim 2, Kamiura fails to disclose the following:

a) a second conductive film.

However, Toshiba discloses the use of a second conductive film (For Example: See Paragraph 12). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a second

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conductive film as disclosed in Toshiba because it aids in improving the element speed (For Example: See Paragraph 12).

Additionally, since Kamiura and Toshiba are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Kamiura.

b) a drive circuit.

However, Toshiba discloses the use of a drive circuit (For Example: See Paragraph 25). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a drive circuit as disclosed in Toshiba because it aids in providing high current drive capacity (For Example: See Paragraph 25).

Additionally, since Kamiura and Toshiba are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Kamiura.

In regards to claims 5 and 6, Kamiura fails to disclose the following:

a) the first conductive film comprises tungsten, and the second gate electrode comprises aluminum.

However, Toshiba discloses the use of a conductive film comprising tungsten and aluminum (For Example: See Paragraph 27). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include conductive film comprising tungsten and aluminum as disclosed in Toshiba because it aids in providing a low contact resistance (For Example: See Paragraph 12).

Additionally, since Kamiura and Toshiba are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Kamiura.

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In regards to claims 7 and 8, Kamiura fails to disclose the following:

a) the n-type impurity region includes an n-type impurity element in concentrations from 1×10^{20} to 1×10^{21} atoms/cm³, the n-type impurity region includes an n-type impurity element in concentrations of from 2×10^{16} to 5×10^{19} atoms/cm³, and the n-type impurity region includes an n-type impurity element in concentrations from 1×10^{16} to 5×10^{19} atoms/cm.³

However, the applicant has not established the critical nature of concentrations from $1x10^{20}$ to $1x10^{21}$ atoms/cm³, $2x10^{16}$ to $5x10^{19}$ atoms/cm³, and $1x10^{16}$ to $5x10^{19}$ atoms/cm³. "The law is replete with cases in which the difference between the claimed invention and the prior art is some range or other variable within the claims. . . In such a situation, the applicant must show that the particular range is critical, generally by showing that the claimed range achieves unexpected results relative to the prior art range." *In re Woodruff*, 919 F.2d 1575, 16 USPQ2d 1934 (Fed. Cir.1990).

In regards to claims 13 and 14, Kamiura discloses the following:

a) the light emitting device is one selected from the group consisting of an EL display, a video camera, a digital camera, a portable computer, a personal computer, a portable telephone, and a car audio stereo (For Example: See Column 1 Lines 14-19).

In regards to claim 39, Kamiura discloses the following:

- a) a semiconductor island on an insulating surface over the substrate (For Example: See Figure 1F);
- b) source and drain regions formed in the semiconductor island (For Example: See Figure 1F);
- c) a channel forming region in the semiconductor island between the source and drain regions (For Example: See Figure 1F);
- d) a pair of lightly doped regions formed between the channel region and the source and drain regions (For Example: See Figure 1F);
- e) a gate electrode formed over the semiconductor island with a gate insulating film interposed therebetween (For Example: See Figure 1F);

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- f) a first conductive film (For Example: See Figure 1F); and
- g) the channel forming region is overlapped by the first conductive film wherein the portions of each of the pair of lightly doped regions are overlapped by the first conductive film, are not overlapped by the gate electrode (For Example: See Figure 1F).

In regards to claim 39, Kamiura fails to disclose the following:

a) a second conductive film.

However, Toshiba discloses the use of a second conductive film (For Example: See Paragraph 12). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a second conductive film as disclosed in Toshiba because it aids in improving the element speed (For Example: See Paragraph 12).

Additionally, since Kamiura and Toshiba are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Kamiura.

In regards to claim 40, Kamiura discloses the following:

- a) a semiconductor island on an insulating surface over the substrate (For Example: See Figure 1F);
- b) source and drain regions formed in the semiconductor island (For Example: See Figure 1F);
- c) a channel forming region in the semiconductor island between the source and drain regions (For Example: See Figure 1F);
- d) a pair of lightly doped regions formed between the channel region and the source and drain regions (For Example: See Figure 1F);
- e) a gate electrode formed over the semiconductor island with a gate insulating film interposed therebetween (For Example: See Figure 1F);
 - f) a first conductive film (For Example: See Figure 1F); and

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g) the channel forming region is overlapped by the first conductive film wherein the portions of each of the pair of lightly doped regions are overlapped by the first conductive film, are not overlapped by the gate electrode (For Example: See Figure 1F).

In regards to claim 40, Kamiura fails to disclose the following:

a) a second conductive film.

However, Toshiba discloses the use of a second conductive film (For Example: See Paragraph 12). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a second conductive film as disclosed in Toshiba because it aids in improving the element speed (For Example: See Paragraph 12).

Additionally, since Kamiura and Toshiba are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Kamiura.

b) a drive circuit.

However, Toshiba discloses the use of a drive circuit (For Example: See Paragraph 25). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a drive circuit as disclosed in Toshiba because it aids in providing a thin film transistor with high current drive capacity (For Example: See Paragraph 25).

Additionally, since Kamiura and Toshiba are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Kamiura.

In regards to claims 43 and 44, Kamiura fails to disclose the following:

a) the first conductive film comprises tungsten, and the second gate electrode comprises aluminum.

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However, Toshiba discloses the use of a conductive film comprising tungsten and aluminum (For Example: See Paragraph 27). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include conductive film comprising tungsten and aluminum as disclosed in Toshiba because it aids in providing a low contact resistance (For Example: See Paragraph 12).

Additionally, since Kamiura and Toshiba are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Kamiura.

In regards to claims 49 and 50, Kamiura discloses the following:

- a) the light emitting device is selected from the group consisting of an EL display, a video camera, a digital camera, a portable computer, a personal computer, a portable telephone, and a car audio stereo (For Example: See Column 1 Lines 14-19).
- 7. Claims 3, 4, 41 and 42 are rejected under 35 U.S.C. 103(a) as obvious over Kamiura et al. (U.S. Patent No. 6,288,413) in view of Toshiba (Japanese Application No. 7-72675) and Yamazaki et al. (U.S. Patent No. 5,627,084).

In regards to claims 3 and 4, Kamiura fails to disclose the following:

a) the first conductive film comprises one of tantalum nitride and titanium nitride, and the second gate electrode comprises tungsten.

However, Yamazaki et al. ("Yamazaki") discloses the use of various conductive films comprising tantalum, titanium, and tungsten (For Example: See Column 3 Lines 7-43 and Column 5 Lines 14-24). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include various conductive films comprising tantalum, titanium, and tungsten as disclosed in Yamazaki because it aids in forming the gate electrode (For Example: See Column 3 Lines 7-43 and Column 5 Lines 14-24).

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Additionally, since Kamiura and Yamazaki are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Yamazaki.

In regards to claims 41 and 42, Kamiura fails to disclose the following:

a) the first conductive film comprises one of tantalum nitride and titanium nitride, and the second gate electrode comprises tungsten.

However, Yamazaki discloses the use of various conductive films comprising tantalum, titanium, and tungsten (For Example: See Column 3 Lines 7-43 and Column 5 Lines 14-24). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include various conductive films comprising tantalum, titanium, and tungsten as disclosed in Yamazaki because it aids in forming the gate electrode (See Column 3 Lines 7-43 and Column 5 Lines 14-24).

Additionally, since Kamiura and Yamazaki are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Yamazaki.

8. Claims 9, 10, 45 and 46 are rejected under 35 U.S.C. 103(a) as obvious over Kamiura et al. (U.S. Patent No. 6,288,413) in view of Toshiba (Japanese Application No. 7-72675) and Zhang (U.S. Patent No. 5,717,224).

In regards to claims 9 and 10, Kamiura fails to disclose the following:

a) the gate electrode is covered by an insulating film comprising a resin film and one of a silicon nitride film and a silicon oxynitride films.

However, Zhang discloses a gate electrode covered by an insulating film comprising a resin film and one of a silicon nitride film and a silicon oxynitride film (For Example: See Column 8 Lines 44-47). It would have been obvious to one having ordinary skill in the art at the

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time the invention was made to modify the semiconductor device of Kamiura to include a gate electrode covered by an insulating film comprising a resin film and one of a silicon nitride film and a silicon oxynitride film as disclosed in Zhang because it aids in keeping the device from shortening out (For Example: See Figure 3c).

Additionally, since Kamiura and Zhang are both from the same field of endeavor, the purpose disclosed by Zhang would have been recognized in the pertinent art of Kamiura.

In regards to claims 45 and 46, Kamiura fails to disclose the following:

a) the gate electrode is covered by an insulating film comprising a resin film and one of a silicon nitride film and a silicon oxynitride films.

However, Zhang discloses a gate electrode covered by an insulating film comprising a resin film and one of a silicon nitride film and a silicon oxynitride film (For Example: See Column 8 Lines 44-47). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a gate electrode covered by an insulating film comprising a resin film and one of a silicon nitride film and a silicon oxynitride film as disclosed in Zhang because it aids in keeping the device from shortening out (For Example: See Figure 3c).

Additionally, since Kamiura and Zhang are both from the same field of endeavor, the purpose disclosed by Zhang would have been recognized in the pertinent art of Kamiura.

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9. Claims 11, 12, 47 and 48 are rejected under 35 U.S.C. 103(a) as obvious over Kamiura et al. (U.S. Patent No. 6,288,413) in view of Toshiba (Japanese Application No. 7-72675), Zhang (U.S. Patent No. 5,717,224) and Shohara et al. (U.S. Patent No. 6,238,754).

In regards to claims 11 and 12, Kamiura fails to disclose the following:

a) a coloring layer is provided between the resin film and the silicon nitride film or between the resin film and the silicon oxynitride film.

However, Shohara discloses a coloring layer provided between the resin film and the silicon nitride film or between the resin film and the silicon oxynitride film (For Example: See Column 13 Lines 7-35). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a coloring layer provided between the resin film and the silicon nitride film or between the resin film and the silicon oxynitride film as disclosed in Shohara because it aids in providing good display characteristics (For Example: See Column 13 Lines 7-35).

Additionally, since Kamiura and Shohara are both from the same field of endeavor, the purpose disclosed by Shohara would have been recognized in the pertinent art of Kamiura.

In regards to claims 47 and 48, Kamiura fails to disclose the following:

a) a coloring layer is provided between the resin film and the silicon nitride film or between the resin film and the silicon oxynitiride film.

However, Shohara discloses a coloring layer is provided between the resin film and the silicon nitride film or between the resin film and the silicon oxynitiride film (For Example: See Column 13 Lines 7-35). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a coloring layer is provided between the resin film and the silicon nitride film or between the resin

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film and the silicon oxynitiride film as disclosed in Shohara because it aids in providing good display characteristics (For Example: See Column 13 Lines 7-35).

Additionally, since Kamiura and Shohara are both from the same field of endeavor, the purpose disclosed by Shohara would have been recognized in the pertinent art of Kamiura.

10. Claims 25, 26, 29-32 and 35-38 are rejected under 35 U.S.C. 103(a) as obvious over Kamiura et al. (U.S. Patent No. 6,288,413) in view of Toshiba (Japanese Application No. 7-72675) and Shohara et al. (U.S. Patent No. 6,238,754).

In regards to claim 25, Kamiura discloses the following:

- a) a channel forming region (For Example: See Figure 1F);
- b) an n-type impurity region adjacent to the channel forming region (For Example: See Figure 1F);
- c) an n-type impurity region adjacent to the n-type impurity region (See Figure 1F);
- d) an n-type impurity region adjacent to the n-type impurity region (For Example: See Figure 1F)
- e) a gate insulating layer provided over the active layer (For Example: See Figure 1F);
- f) a gate electrode provided over the gate insulating layer (For Example: See Figure 1F);
- g) a first conductive film provided over the gate insulating layer (For Example: See Figure 1F); and
- h) first conductive film overlaps the channel forming region and the n type impurity region with the gate insulating layer interposed therebetween (For Example: See Figure 1F).

In regards to claim 25, Kamiura fails to disclose the following:

a) a second conductive film.

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However, Toshiba discloses the use of a second conductive film (For Example: See Paragraph 12). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a second conductive film as disclosed in Toshiba because it aids in improving the element speed (For Example: See Paragraph 12).

Additionally, since Kamiura and Toshiba are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Kamiura.

b) a coloring layer

However, Shohara discloses a coloring layer (For Example: See Column 13 Lines 7-35). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a coloring layer as disclosed in Shohara because it aids in providing good display characteristics (For Example: See Column 13 Lines 7-35).

Additionally, since Kamiura and Shohara are both from the same field of endeavor, the purpose disclosed by Shohara would have been recognized in the pertinent art of Kamiura.

In regards to claim 26, Kamiura discloses the following:

- a) a channel forming region (For Example: See Figure 1F);
- b) an n-type impurity region adjacent to the channel forming region (For Example: See Figure 1F);
- c) an n-type impurity region adjacent to the n-type impurity region (For Example: See Figure 1F);
- d) an n-type impurity region adjacent to the n-type impurity region (For Example: See Figure 1F);

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- e) a gate insulating layer provided over the active layer (For Example: See Figure 1F);
- f) a gate electrode provided over the gate insulating layer (For Example: See Figure 1F);
- g) a first conductive film provided over the gate insulating layer (For Example: See Figure 1F); and
- h) first conductive film overlaps the channel forming region and the n type impurity region with the gate insulating layer interposed therebetween (For Example: See Figure 1F).

In regards to claim 26, Kamiura fails to disclose the following:

a) a second conductive film.

However, Toshiba discloses the use of a second conductive film (For Example: See Paragraph 12). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a second conductive film as disclosed in Toshiba because it aids in improving the element speed (For Example: See Paragraph 12).

Additionally, since Kamiura and Toshiba are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Kamiura.

b) a drive circuit.

However, Toshiba discloses the use of a drive circuit (For Example: See Paragraph 25). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a drive circuit as disclosed in Toshiba because it aids in providing high current drive capacity (For Example: See Paragraph 25).

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Additionally, since Kamiura and Toshiba are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Kamiura.

c) a coloring layer

However, Shohara discloses a coloring layer (For Example: See Column 13 Lines 7-35). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a coloring layer as disclosed in Shohara because it aids in providing good display characteristics (For Example: See Column 13 Lines 7-35).

Additionally, since Kamiura and Shohara are both from the same field of endeavor, the purpose disclosed by Shohara would have been recognized in the pertinent art of Kamiura.

In regards to claims 29 and 30, Kamiura fails to disclose the following:

a) the first conductive film comprises tungsten, and the second gate electrode comprises aluminum.

However, Toshiba discloses the use of a conductive film comprising tungsten and aluminum (For Example: See Paragraph 27). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include conductive film comprising tungsten and aluminum as disclosed in Toshiba because it aids in providing a low contact resistance (For Example: See Paragraph 12).

Additionally, since Kamiura and Toshiba are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Kamiura.

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In regards to claims 31 and 32, Kamiura fails to disclose the following:

a) the n-type impurity region includes an n-type impurity element in concentrations from 1×10^{20} to 1×10^{21} atoms/cm³, the n-type impurity region includes an n-type impurity element in concentrations of from 2×10^{16} to 5×10^{19} atoms/cm³, and the n-type impurity region includes an n-type impurity element in concentrations from 1×10^{16} to 5×10^{19} atoms/cm³

However, the applicant has not established the critical nature of concentrations from $1x10^{20}$ to $1x10^{21}$ atoms/cm³, $2x10^{16}$ to $5x10^{19}$ atoms/cm³, and $1x10^{16}$ to $5x10^{19}$ atoms/cm³. "The law is replete with cases in which the difference between the claimed invention and the prior art is some range or other variable within the claims. . . . In such a situation, the applicant must show that the particular range is critical, generally by showing that the claimed range achieves unexpected results relative to the prior art range." *In re Woodruff*, 919 F.2d 1575, 16 USPQ2d 1934 (Fed. Cir.1990).

In regards to claims 35 and 36, Kamiura fails to disclose the following:

a) a coloring layer is provided between the resin film and the silicon nitride film or between the resin film and the silicon oxynitiride film.

However, Shohara discloses a coloring layer provided between the resin film and the silicon nitride film or between the resin film and the silicon oxynitiride film (For Example: See Column 13 Lines 7-35). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a coloring layer provided between the resin film and the silicon nitride film or between the resin film and the silicon oxynitiride film as disclosed in Shohara because it aids in providing good display characteristics (For Example: See Column 13 Lines 7-35).

Additionally, since Kamiura and Shohara are both from the same field of endeavor, the purpose disclosed by Shohara would have been recognized in the pertinent art of Kamiura.

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In regards to claims 37 and 38, Kamiura discloses the following:

- a) the light emitting device one is selected from the group consisting of an EL display, a video camera, a digital camera, a portable computer, a personal computer, a portable telephone, and a car audio stereo (For Example: See Column 1 Lines 14-19).
- 11. Claims 27 and 28 are rejected under 35 U.S.C. 103(a) as obvious over Kamiura et al. (U.S. Patent No. 6,288,413) in view of Toshiba (Japanese Application No. 7-72675), Shohara et al. (U.S. Patent No. 6,238,754) and Yamazaki et al. (U.S. Patent No. 5,627,084).

In regards to claims 27 and 28, Kamiura fails to disclose the following:

a) the first conductive film comprises one of tantalum nitride and titanium nitride, and the second gate electrode comprises tungsten.

However, Yamazaki discloses the use of various conductive films comprising tantalum, titanium, and tungsten (For Example: See Column 3 Lines 7-43 and Column 5 Lines 14-24). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include various conductive films comprising tantalum, titanium, and tungsten as disclosed in Yamazaki because it aids in forming the gate electrode (For Example: See Column 3 Lines 7-43 and Column 5 Lines 14-24).

Additionally, since Kamiura and Yamazaki are both from the same field of endeavor, the purpose disclosed by Toshiba would have been recognized in the pertinent art of Yamazaki.

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12. Claims 33 and 34 are rejected under 35 U.S.C. 103(a) as obvious over Kamiura et al. (U.S. Patent No. 6,288,413) in view of Toshiba (Japanese Application No. 7-72675), Shohara et al. (U.S. Patent No. 6,238,754) and Zhang (U.S. Patent No. 5,717,224).

In regards to claims 33 and 34, Kamiura fails to disclose the following:

a) the gate electrode is covered by an insulating film comprising a resin film and one of a silicon nitride film and a silicon oxynitride films.

However, Zhang discloses a gate electrode covered by an insulating film comprising a resin film and one of a silicon nitride film and a silicon oxynitride film (For Example: See Column 8 Lines 44-47). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor device of Kamiura to include a gate electrode covered by an insulating film comprising a resin film and one of a silicon nitride film and a silicon oxynitride film as disclosed in Zhang because it aids in keeping the device from shortening out (For Example: See Figure 3c).

Additionally, since Kamiura and Zhang are both from the same field of endeavor, the purpose disclosed by Zhang would have been recognized in the pertinent art of Kamiura.

Response to Arguments

Applicant's arguments filed August 26, 2003 have been fully considered but they are not persuasive. Applicant argues that the prior art does "not teach or suggest either that an n-type impurity region (c) is overlapped by a conductive film or that an n-type impurity region (b) is not overlapped by a conductive film." However, the prior art disclose the first conductive film (8) overlaps the channel forming region and the n-type impurity region (c) (5) with the gate insulating layer (3) interposed between (For Example: See Figure 1F). Finally Applicant argues that "Kamiura does not teach or suggest the importance of an n-type impurity region (c) which is

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overlapped by a conductive film, which is a means for hot carrier deterioration. In response to applicant's argument stated above, the fact that applicant has recognized another advantage which would flow naturally from following the suggestion of the prior art cannot be the basis for patentability when the differences would otherwise be obvious. See *Ex parte Obiaya*, 227 USPQ 58, 60 (Bd. Pat. App. & Inter. 1985). Therefore, Applicant's arguments are not persuasive.

Conclusion

14. THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

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15. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Monica Lewis whose telephone number is 703-272-1838.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Amir Zarabian can be reached on 703-272-1852. The fax phone number for the organization where this application or proceeding is assigned is 703-308-7722 for regular and after final communications. Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

ML December 24, 2003

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